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Application Serial No. .... 10/820,575  
Filing Date .... April 7, 2004  
Inventor .... Scott E. Moore et al.  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 2877  
Examiner .... Roy Punnoose  
Attorney's Docket No. .... MI22-2493  
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 11/16/06By: 

James D. Shaurette  
Reg. No. 39,833